

ATTACHMENT A

25. (currently amended) ~~An excimer or molecular fluorine laser system, comprising:~~

~~a discharge chamber filled with a laser gas mixture at least including a halogen-containing molecular species and a buffer gas;~~

~~a plurality of electrodes within the discharge chamber connected to a discharge circuit for energizing the gas mixture; and~~

~~a resonator for generating a laser beam including~~ The laser system of claim 1, wherein the MgF_2 window is a partially reflecting output coupler, and

~~wherein said output coupler comprises an MgF_2 substrate oriented such that the crystallographic c-axis of the MgF_2 material of the output coupler is at least approximately parallel to a beam path through said output coupler.~~